## Confinement and Processing Can Alter the Morphology and Periodicity of Bottlebrush Block Copolymers in Thin Films

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## Supporting Information

Figure S1: AFM height image of gPS-*b*-gPLA blade coated out of a THF solution at a thickness of 90 nm prior to annealing.



Figure S2: AFM phase image of gPS-*b*-gPLA blade coated out of a THF solution at a thickness of 110 nm after annealing at 165 °C for 24 hrs.



Figure S3: AFM phase image of gPS-*b*-gPLA blade coated out of a THF solution at a thickness of 50 nm after annealing at 165 °C for 24 hrs. The PSD yields a broad peak centered around 85 nm.